



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 8920

SERIAL NUMBER 10/800,112	FILING OR 371(c) DATE 03/12/2004 RULE	CLASS 216	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 008245/DSM/BCVD
APPLICANTS Yuxiang May Wang, Palo Alto, CA; David R. Bittrich, Madison, WI; Christopher Dennis Bencher, San Jose, CA; Heraldo L. Botelho, Palo Alto, CA; Sudha S. R. Rath, San Jose, CA; Michael Chiu Kwan, Sunnyvale, CA;				
** CONTINUING DATA *****				
** FOREIGN APPLICATIONS *****				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 07/31/2004				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>[Signature]</i> Allowance Examiner's Signature Initials		STATE OR COUNTRY CA	SHEETS DRAWING 1	TOTAL CLAIMS 22 INDEPENDENT CLAIMS 3
ADDRESS 44257				
TITLE Method of depositing an amorphous carbon film for metal etch hardmask application				
FILING FEE RECEIVED 936	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	